Large-area synthesis of monolayer MoSe$_2$ films on SiO$_2$/Si substrates by atmospheric pressure chemical vapor deposition

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We report the synthesis of large-scale continuous MoSe$_2$ films on SiO$_2$/Si substrates by atmospheric pressure chemical vapor deposition (CVD). As-grown thin films were composed of a continuous monolayer of MoSe$_2$ and extended up to a millimeter scale. The CVD-grown monolayer MoSe$_2$ films were uniform in thickness and highly crystalline with hexagonal crystal structures. Raman and photoluminescence spectra showed that CVD-grown monolayer MoSe$_2$ films have similar vibrational and optical properties to those of mechanically exfoliated monolayer MoSe$_2$. These results demonstrate that the CVD-grown monolayer MoSe$_2$ films have reasonably high quality comparable to that of mechanically exfoliated monolayer MoSe$_2$ flakes.

Introduction

In recent years, transition metal dichalcogenides (TMDs) with an atomically thin two-dimensional layer structure have attracted enormous attention because of their excellent electronic and optical properties.$^{1-8}$ The band gap of TMDs semiconductors (1–2 eV) makes them promising candidates for the channel materials of field-effect transistors (FETs).$^9-11$ Moreover, TMDs materials such as MoS$_2$ or MoSe$_2$ show indirect-to-direct bandgap transition when their thickness decreases down to monolayer.$^{12,13}$ This suggests that monolayer TMDs semiconductors are very promising for potential applications in optoelectronic devices such as photo detectors.$^{14,15}$

So far, various methods have been tried to obtain large-area TMDs films as the synthesis of large-area TMDs is one of the critical challenges for their real applications. Most emphasis has been put on MoS$_2$. Mechanical exfoliation provides high-quality crystalline flakes. But, their size is limited, the number of layer is uncontrollable, and the product yield is very low.$^{4,16,17}$ Chemical exfoliation and electrochemical exfoliation provide a simple and easy way but obtained flakes are small in the size and uncontrollable in thickness.$^{18-19}$ Sulfurization of transition metals or transition metal oxides provides large-area films, but obtained films show uncontrollable thickness uniformity.$^{20}$ In comparison, chemical vapor deposition (CVD) with solid-phase precursors (such as S and MoO$_3$ powder) can provide an effective method to synthesize monolayer MoS$_2$ with reasonable quality on different substrates including SiO$_2$/Si wafers, metal foils, or sapphire wafers.$^{21-24}$ Moreover, CVD with metalorganic (MO) precursors can provide wafer-scale continuous MoS$_2$ films.$^{25}$

The use of MoSe$_2$ could be more suitable than MoS$_2$ for the application of tunnel FETs, optoelectronic devices and spintronic devices with its narrower bandgap,$^{13}$ higher optical absorbance$^{26}$ and larger spin-splitting energy$^{27}$ than MoS$_2$. However, compared to CVD-grown monolayer MoS$_2$, there have been much less reports on CVD-grown monolayer MoSe$_2$.$^{28-37}$ Thin films of MoSe$_2$ has not yet been obtained by CVD with MO precursors. Furthermore, it is much more difficult to synthesize monolayer MoSe$_2$ films by CVD with solid-phase precursors than monolayer MoS$_2$ films because of the low chemical reactivity of Se. CVD with solid-phase precursors commonly results in triangular-shaped discontinuous domains of either single-layer MoSe$_2$ or mixtures of single- and few-layer MoSe$_2$.$^{28-30,32-35,37}$ While continuous thin films of monolayer MoSe$_2$ can be obtained on substrates up to about 1 cm$^2$ in size by meticulously tuning and optimizing experimental parameters of low pressure CVD processes,$^{26}$ continuous MoSe$_2$ films with such size have not yet been reported by atmospheric pressure CVD. As atmospheric pressure CVD can allow higher deposition rate and lower substrate temperature than low pressure CVD in general, it is still of interest to synthesize large-area MoSe$_2$ films with a uniform thickness by atmospheric pressure CVD. Here, we demonstrate the synthesis of large-area monolayer MoSe$_2$ films extended up to a millimeter scale on SiO$_2$/Si substrates by atmospheric pressure CVD. The obtained monolayer MoSe$_2$ shows very uniform film thickness, good continuity, highly crystalline hexagonal crystal structures.

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Furthermore, we compare for the first time the vibrational and optical properties of monolayer MoSe₂ thin films to those of mechanically exfoliated monolayer MoSe₂ single crystals.

**Experimental**

The schematic illustration of the synthesis of MoSe₂ films is shown in Fig. 1. The atmospheric pressure CVD reaction was carried out using a two-zone horizontal tube furnace with a one inch diameter quartz tube. Se powder was loaded in an alumina boat at the center of zone 1, and MoO₃ powder was loaded in an alumina boat at the center of zone 2. A 300 nm-SiO₂/Si substrate was located at the center of zone 2 with its face down on another alumina boat. During the synthesis of MoSe₂ film, zone 1 was heated to 300 °C with flowing Ar/H₂ carrier gases under atmospheric pressure while zone 2 was heated to 750 °C. The Ar and H₂ flow rates were 1500 sccm and 150 sccm, respectively. Se powder was evaporated at the center of zone 1 and transported to zone 2 downstream by Ar carrier gas, and MoO₃ powder was reduced by H₂ gas at the same time. The selenization of vapor-phase Mo produced nucleation of MoSe₂ species on the SiO₂/Si substrate. Finally, the nucleated MoSe₂ species grew into large-area MoSe₂ films. It is well understood that hydrogen plays a critical role in the growth of MoSe₂ films as an additional reducing agent with Se and MoO₃ powder precursors. MoSe₂ films were not observed on the substrates without H₂ gas.

**Results and discussion**

Fig. 2(a)–(d) show the optical images of as-grown MoSe₂. The area covered with monolayer MoSe₂ looks dark while uncovered area looks bright. The monolayer MoSe₂ films with several hundred micrometers were found on SiO₂/Si substrates as shown in Fig. 2(a) and (b) (we intentionally scratched the surface to leave the pink colored line). Fig. 2(c) shows some triangular domains of MoSe₂ with several micrometers on SiO₂/Si substrates. Those domains merge together and become a continuous and large-area film up to several hundred micrometers. Partly some triangular domains are folded, resulting in bilayers or triple layers as shown in Fig. 2(d). The homogeneous color of MoSe₂ films in optical images suggests that the as-grown MoSe₂ films have good continuity and uniformity. Atomic force microscopy (AFM) was used to measure the morphology and the thickness of the MoSe₂ films. Fig. 2(e) and (f) show the AFM image and the height of as-grown MoSe₂ film on the SiO₂/Si substrate, respectively. The measured height is about 0.7 nm, which is consistent with the thickness of mechanically exfoliated monolayer MoSe₂ flakes.

Raman spectrum is an effective method to characterize layer numbers of TMDs materials. Fig. 3(a) shows the Raman spectra of as-grown mono-, bi-, and multilayer MoSe₂ films with
a 514 nm excitation laser. There are two main peaks in the Raman spectra, one is a sharp peak at low wavenumber corresponding to $A_{1g}$ mode (out of plane vibration), and another is a broad peak at high wavenumber corresponding to $E_{2g}$ mode (in plane vibration). In general, the location of Raman modes can be used to determine the thickness of TMDs materials. In this work, the $A_{1g}$ and $E_{2g}$ modes of monolayer MoSe$_2$ films are located at 239.2 and 290.3 cm$^{-1}$, respectively, which is well agreed with the previous results of 2H-phase exfoliated monolayer MoSe$_2$ flakes and CVD-grown monolayer MoSe$_2$ films.\textsuperscript{15,34} As the thickness of MoSe$_2$ film increases from monolayer to multilayer, the $A_{1g}$ mode is blue-shifted to 240.2 cm$^{-1}$, and the $E_{2g}$ mode is red-shifted to 285.9 cm$^{-1}$. Similar results were also previously reported by other groups.\textsuperscript{15,30,32,33}

In order to confirm the bandgap of CVD-grown MoSe$_2$ films, photoluminescence (PL) spectra were measured. Fig. 3(b) shows the PL spectra of mono- $\beta_i$, and multilayer $\beta_i$ films. A monolayer MoSe$_2$ film shows a high intensity peak at 790 nm (1.57 eV), which can be ascribed to the direct bandgap at $K$ point of Brillouin zone.\textsuperscript{31} The observed PL emission at 1.57 eV is in good agreement with the reported values in literature.\textsuperscript{32,33} The bandgap of MoSe$_2$ changes from direct to indirect as the thickness increases from monolayer to multilayer. This significantly decreases PL peak intensity.\textsuperscript{34} The PL peak of bilayer MoSe$_2$ films is red-shifted to 810 nm (1.53 eV), and the peak intensity is approximately 15 times weaker than that of monolayer MoSe$_2$ films. This is also in good agreement with the results on MoSe$_2$ bilayer in literature.\textsuperscript{33} Moreover, it is difficult to find noticeable peak intensity for multilayer MoSe$_2$ films.

It is well known that Raman mapping can further confirm uniformity and continuity of the CVD-grown MoSe$_2$ films. Fig. 3(c) and (d) show Raman mapping of monolayer MoSe$_2$ films in the area of $40 \times 40$ $\mu$m$^2$ where the distribution in $A_{1g}$ and $E_{2g}$ mode is presented, respectively. The uniform color of the two mapping images indicates that the CVD-grown MoSe$_2$ films have considerably good uniformity and continuity. Raman and PL analysis suggests that our CVD-grown monolayer MoSe$_2$ films are uniform in thickness.

In order to investigate elemental composition and binding energy of the as-grown monolayer MoSe$_2$ films, X-ray photoelectron spectroscopy (XPS) was used. Carbon binding energy was set as a reference to remove any effects of charge accumulation on these samples, and the backgrounds were estimated as Shirley-type.\textsuperscript{38} Fig. 4(a) shows that MoSe$_2$ films have the binding energy of 229.1 and 232.2 eV at Mo 3d$_{5/2}$ and 3d$_{3/2}$ peaks, respectively. In this work, the binding energies of Mo are significantly shifted from those of hexavalent Mo (232.5 and 235.9 eV), suggesting the reduction of Mo from Mo$^{\text{VI}}$ (MoO$_3$) to Mo$^{\text{IV}}$.\textsuperscript{39} Fig. 4(b) shows the binding energies of 54.5 and 55.3 eV corresponding to divalent Se ions (Se 3d$_{5/2}$ and 3d$_{3/2}$, respectively). It is worth noting that XPS results are consistent with previous works in literature confirming the chemical valence states of the CVD-grown monolayer MoSe$_2$ films.\textsuperscript{38,39}

The crystal structure of CVD-grown monolayer MoSe$_2$ films was characterized using transmission electron microscopy (TEM). The MoSe$_2$ films were transferred to a carbon-coated Cu TEM grid. Fig. 5(a) shows that the transferred MoSe$_2$ film has good continuity but some folds and small particles exist due to residual organics or unskillful transfer technique. Fig. 5(b) shows a triangular grain with several micrometers in size inside a continuous MoSe$_2$ film, indicating the polycrystalline nature of CVD-grown monolayer MoSe$_2$ films. Fig. 5(c) shows a TEM image of a monolayer MoSe$_2$ film with a corresponding fast Fourier transformation (FFT) pattern in the inset. The FFT pattern exhibits clear six-fold

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**Fig. 4** XPS characterization of monolayer MoSe$_2$ film. (a) XPS spectra of Mo 3d binding energy and (b) XPS spectra of Se 3d binding energy.
exfoliated monolayer MoSe$_2$ reasonably high quality comparable to that of the mechanically exfoliated monolayer MoSe$_2$ film.

 symmetry of diffraction spots, demonstrating single layer MoSe$_2$ film with a hexagonal structure. Fig. 5(d) shows a TEM image of a bilayer MoSe$_2$ film with a corresponding FFT pattern in the inset. The FFT pattern indicates a twist between two layers with additional six diffraction spots. Fig. 5(e) clearly demonstrates the expected hexagonal crystal structure of monolayer MoSe$_2$ in the high resolution TEM (HRTEM) image. The lattice constant is ~0.3 nm, which is well agreed with the previous results of monolayer MoSe$_2$.\textsuperscript{28,30,31,33} HRTEM images and FFT patterns confirm the high crystallinity of the CVD-grown monolayer MoSe$_2$ films.

It needs to be mentioned that, while perfect 2H-phase MoS$_2$ is known to be inert, defects such as vacancies and grain boundaries in real MoS$_2$ can lead to poor long-term stability in air.\textsuperscript{40,41} As a theoretical calculation predicts comparable oxidation behavior between single layer MoS$_2$ and MoSe$_2$,\textsuperscript{40} we expect our CVD-grown MoSe$_2$ thin films could be more resistant to oxidation with improved crystallinity in the future.

Finally, the quality of the CVD-grown monolayer MoSe$_2$ film was compared to a mechanically exfoliated monolayer MoSe$_2$ flake through Raman and PL spectra. Fig. 6(a) shows that Raman spectrum of CVD-grown monolayer MoSe$_2$ film is consistent with that of an exfoliated monolayer MoSe$_2$ flake, which indicates the high quality of the CVD-grown monolayer MoSe$_2$ film. Even though the PL spectrum in Fig. 6(b) shows that the emission peak of CVD-grown monolayer MoSe$_2$ film exhibits very similar intensity and energy to those of the mechanically exfoliated monolayer MoSe$_2$ flake, the CVD-grown monolayer MoSe$_2$ film shows a slightly wider full-width at half-maximum of PL peak than that of the mechanically exfoliated monolayer MoSe$_2$ flake. It may imply that the CVD-grown monolayer MoSe$_2$ film has a little higher defect density than that of the mechanically exfoliated monolayer MoSe$_2$ flake. In fact, the interpretation of the crystal quality by optical analysis like Raman or PL is complicated to assess the crystal quality of two-dimensional materials.\textsuperscript{42} Nevertheless, these results suggest that the CVD-grown monolayer MoSe$_2$ film has reasonably high quality comparable to that of the mechanically exfoliated monolayer MoSe$_2$ flake.

Conclusions

We investigated the synthesis of large-area monolayer MoSe$_2$ films on SiO$_2$/Si substrates by atmospheric pressure CVD. The CVD-grown monolayer MoSe$_2$ exhibited continuous and large-scale films with uniform thickness. The HRTEM images with corresponding FFT patterns revealed that CVD-grown monolayer MoSe$_2$ films have hexagonal crystal structure with high crystallinity. Raman and PL spectra analysis showed that the CVD-grown monolayer MoSe$_2$ films have comparable vibrational and optical properties with those of mechanically exfoliated monolayer MoSe$_2$ flakes. These results demonstrate that our large-area CVD-grown monolayer MoSe$_2$ films have reasonably high quality comparable to that of the mechanically exfoliated monolayer MoSe$_2$ flake. We suggest that our large-area and high quality CVD-grown monolayer MoSe$_2$ films can expand understanding on the synthesis of TMDs materials, providing potentially important implications on their applications in various electronic and photonic devices in the future.

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References
